

Date: July 13, 2005

Inventor(s): Richard S. Belliveau

Title: Theatrical fog particle protection system for image projection lighting devices

Date Filed: 09/08/2003

Serial No.: 10/657,630

### SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir or Madam:

Applicant submits this statement in accordance with the duty of disclosure under 37 C.F.R. 1.56 and 1.97-1.98. The additional fee for a supplemental IDS of \$180.00 under 37 C.F.R. 1.17(p) is enclosed.

The English language references are listed on attached Form PTO-1449 and require no further commentary under 37 C.F.R. 1.98(a)(3).

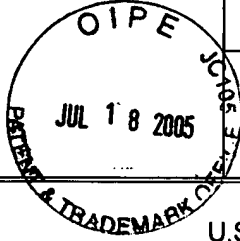
A copy of each reference, together with a listing on Form PTO-1449, is submitted herewith. Applicant respectfully solicits the Examiner's consideration of the cited references and entry thereof into the record of this application.

Respectfully submitted,

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## Section 2. Form PTO - 1449 (Modified)

FORM PTO-1449 U.S. Department of Commerce (Modified) PATENT AND TRADEMARK OFFICE  INFORMATION DISCLOSURE STATEMENT BY APPLICANT  (Use several sheets if necessary)  (37 CFR 1.98(b))	ATTY. DOCKET NO.: Belliveau - 18	SERIAL NO.: 10/657,630
	APPLICANT(S): Richard Belliveau	
	FILING DATE: 09/08/2003	GROUP



## U.S. PATENT DOCUMENTS

EXAMINE R INITIAL		PATENT NUMBER							ISSUE DATE	PATENTEE	CLASS	SUB- CLASS	FILING DATE IF APPROPRI ATE
		6	7	6	5	5	4	4	07/20/2004	Wynne Willson	345/6		10/20/2000
		6	0	9	9	1	2	8	08/08/2000	Jessl	353/51		10/21/1997
		6	6	7	1	0	0	5	12/30/2003	Pujol et al.	348/771		06/21/1999
		6	5	8	8	9	4	4	07/08/2003	Harris	385/88		1/29/2001
		6	4	1	2	9	7	2	07/02/2002	Pujoletal.	362,272		12/10/1999

## FOREIGN PATENT OR PUBLISHED FOREIGN PATENT APPLICATION

		DOCUMENT NUMBER							PUBLICATIO N DATE	COUNTRY OR PATENT OFFICE	CLASS	SUBCLAS S	TRANSLATION YES NO	

## OTHER DOCUMENTS (Including Author, Title, Date, Relevant Pages, Places of Publication")


EXAMINER

DATE CONSIDERED

EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.